

APPROPRIATE 26 APR 2006

033082M322

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Youngchul Park, et al.

International Application No.: PCT/JP2004/016213

International Filing Date: November 1, 2004

U.S. Serial No.: To Be Assigned

Group Art Unit: To Be Assigned

Filed: : Herewith

Examiner: To Be Assigned

For: THERMAL PROCESSING APPARATUS AND THERMAL
PROCESSING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

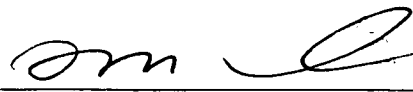
Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists all of the documents noted in the International Search Report (ISR) filed herewith. Copies of the cited documents are enclosed. According to the Search Report, U.S. Publication No. 2002/0045146 (document AA on the enclosed Form PTO-1449) is a family member of JP 2002-091574 (document AH). Document AB has been cited and described on pages 1 and 2 of Applicants' specification.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,

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By:



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April 26, 2006

APPROPRIATE TO 23 APR 2006

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET 033082M322	SERIAL NO. 45 To Be Assigned
	APPLICANT: Youngchul Park, et al.	
	FILING DATE Herewith	GROUP ART UNIT To Be Assigned

U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE, IF APPROPRIATE
	AA	2002/0045146	4/18/02	Wang, et al.			
	AB	5,517,594	5/14/96	Shah et al.			
	AC						
	AD						
	AE						
	AF						
	AG						

FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO	
	AH	2002-091574	3/29/02	Japan			Abstract	
	AI	2002-043226	2/8/02	Japan			Abstract	
	AJ	2005-026397	1/27/05	Japan			Abstract	
	AK							
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	AQ	
	AR	
	AS	

EXAMINER: /Maureen Gramaglia/	DATE CONSIDERED: 09/20/2009
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.